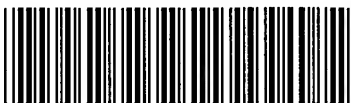


Search Notes

Application/Control No.

10/770,886

Examiner

David P. Stitzel, Esq.

Applicant(s)/Patent under
Reexamination

SEMBO, SATOSHI

Art Unit

1616

SEARCHED

Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
STN (see attached search notes)	3/20/2006	DPS